

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kenji ITOGA, et al.

Application No.: 09/769,490

I'iled: January 26, 2001

For:

X-RAY EXPOSURE APPARATUS, X-RAY EXPOSURE METHOD, X-RA X-RAY MIRROR, SYNCHROTRON RADIATION APPARATUS, SYNCHR

Group Art Unit: 2882

Examiner: C. Kao

RADIATION METHOD AND SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. § 1.116

Box AF The Commissioner for Patents and Trademarks Washington, DC 20231

Sir:

The following Amendment and Remarks are submitted in response to the Final Office Action dated May 23, 2002, pursuant to the provisions of 37 C.F.R. § 1.116. Please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claim 16 as follows:

16. (Thrice Amended) An X-ray mirror containing one type of material for a mirror selected from the group consisting of titanium, silver, and nitride thereof, a carbide thereof, a boride thereof, diamond, diamond-like carbon, and boron nitride, and wherein